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Docket No. 1232-5336

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Seiya MIURA

Group Art Unit: 2851

Serial No.: 10/798,817

Examiner: Peter Kim

Filed: March 10, 2004

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE  
MANUFACTURING METHOD

**AMENDMENT PURSUANT TO 37 C.F.R. §1.111**

Mail Stop **Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action dated September 7, 2005, Applicant respectfully requests reconsideration in view of the following amendments and remarks.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.